## Notice of References Cited Examiner Daniel J. Colilla Applicant(s)/Patent Under Reexamination YAMAGUCHI, HIDEYUKI Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	_ <u>u</u>	Machine translation of JP 8-332785 to Tanaka et al. from Japanese Patent Office website.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYYY format are publication dates. Classifications may be US or foreign.